## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	:	09/546,174		Confirmation No.:	4793
Applicant		Chih-Chien Liu			
Filing Date	*	April 11, 2000			
Title	:	HIGH DENSITY PROCESS	PLASMA CHE	EMICAL VAPOR DEPO	SITION
Group Art U	Init:	1796			
Examiner	:	Sergent, Rabor	ı A.		
Docket No.	:	20952.4002			
Customer N	lo. :	34313			
Commissior Mail Stop Al P.O. Box 14 Alexandria,	F  50			RESPONSE UNDE 1.116 EXPEDITED PR EXAMINING GF 4793	ROCEDURE
			·		
	AMEN	DMENT TRANSM	ITTAL AFTER	FINAL REJECTION	
above-ident	ified app		to the Notice	ction (37 CFR 1.116) in of Appeal on June 13, 2 008.	
⊠ If an a		al extension of time	e is required, pl	ease consider this a pe	tition
⊠ Attac	hed is a	General Power Att	orney.		
⊠ Attac	hed is St	tatement Under 37	CFR 3.73(b).		
There is no	fee requ	ired:			
Fee Calculati A.			•	zed to charge indicated fe	es and
				Account No. <u>15-0665</u> nder 37 CFR 1.16 and 1.	17 to
В.		Deposit Account No Payment Enclosed	<u>15-0665</u> .		
		Check	Credit Card	☐ Money Order ☐	Other

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Sergent, Rabon A. 20952.4002

		00.90
Docket No.	:	20952.4

Total Claims	40		49		0	Х	\$50.00	0		
Independent Claims	3	-	3	=	0	Х	\$210.00	0		
Multiple Dependent Claims \$370 (if applicable)										
TOTAL OF ABOVE CALCULATIONS										
Reduction by ½ for Filing by Small Entity. Note 37 CFR §§ 1.9, 1.27, 1.28.										
Extension of Time (from above)								0		
Assignment \$40 (if applicable)										
TOTAL FEES SUBMITTED HEREWITH								0		

Respectfully submitted,

ORRICK, HERRINGTON & SUTCLIFFE LLP

Dated: 8-12-08

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